



**ELECTRONIC COPY**

LG760503819  
Report verification at igi.org



December 25, 2025

IGI Report Number **LG760503819**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **9.79 X 7.13 X 4.44 MM**

**GRADING RESULTS**

Carat Weight **1.99 CARAT**

Color Grade **E**

Clarity Grade **VVS 2**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

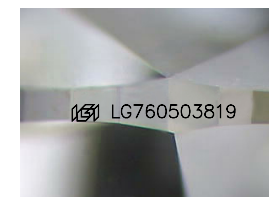
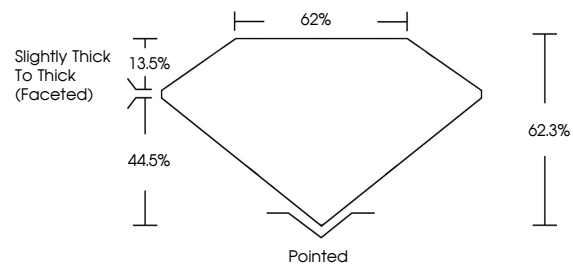
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG760503819**

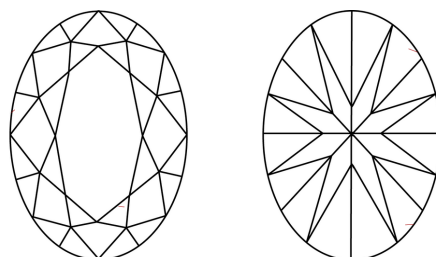
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

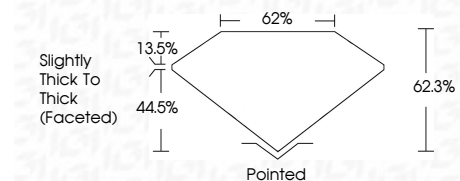
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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OVAL BRILLIANT  
1.99 CARAT E  
9.79 X 7.13 X 4.44 MM  
Carat Weight  
Color Grade  
Clarity Grade  
Depth  
Table  
Girdle  
Slightly Thick To Thick (Faceted)  
62.3% 62%  
Pointed  
Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG760503819  
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